

Notice of References Cited	Application/Control No. 09/966,316	Applicant(s)/Patent Under Reexamination MIS ET AL.	
	Examiner William C. Vesperman	Art Unit 2813	Page 1 of 1

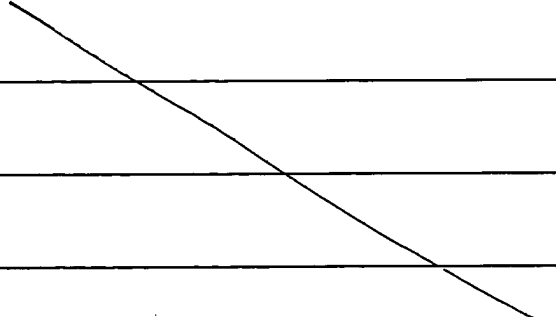
U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,335,104	01-2002	Sambucetti et al.	428/615
*	B	US-2001/0011764	08-2001	ELENIUS et al.	257/679
*	C	US-6,221,682	04-2001	Danziger et al.	438/15
*	D	US-6,419,974	07-2002	Silva et al.	426/580
*	E	US-2002/0086520	07-2002	Chiang, Ching Hua	438/630
*	F	US-5,162,257	11-1992	Yung, Edward K.	438/613
*	G	US-6,208,018	03-2001	Ma et al.	257/669
*	H	US-5,886,393	03-1999	Merrill et al.	257/531
*	I	US-5,902,686	05-1999	Mis, Joseph Daniel	428/629
*	J	US-2002/0197842	12-2002	Kuo et al.	438/613
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
*	N	EP 0 782 191 A2	12-1996	GB	Degani	H01L 25/065
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.